



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Robert J. Small; Maria Peterson; Tuan Truong; Melvin Keith Carter;
and Lily Yao
Assignee: EKC Technology, Inc.
Title: Compositions For Chemical Mechanical Planarization Of Copper
Serial No.: 10/017,934 Filed: December 12, 2001
Examiner: Unknown Group Art Unit: 1765
Docket No.: M-11675 US

San Francisco, California
March 7, 2002

NOTICE OF CHANGE OF ADDRESS

COMMISSIONER FOR PATENTS
Washington, D. C. 20231

Sir:

Please direct all correspondence in the above-identified application and with respect
to any patent that issues on this application to the undersigned at this address:

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Respectfully submitted,

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